

SHEET 1 OF 1

FORM PTO-1449  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO. 2933SE-11-CIP-2	SERIAL NO. 09/037,674
	APPLICANT MIZUHARA et al.	
	FILING DATE March 9, 1998	GROUP ART 2814

## OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

	A1.	Wolf, et al., "Silicon Processing for the VLSI Era: Volume 1 - Process Technology", Lattice Press, 1986, page 441.
	A2.	Wolf, "Silicon Processing for the VLSI Era: Volume 2 - Process Integration", Lattice Press, 1990, pages 232-233.

EXAMINER	DATE CONSIDERED
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	